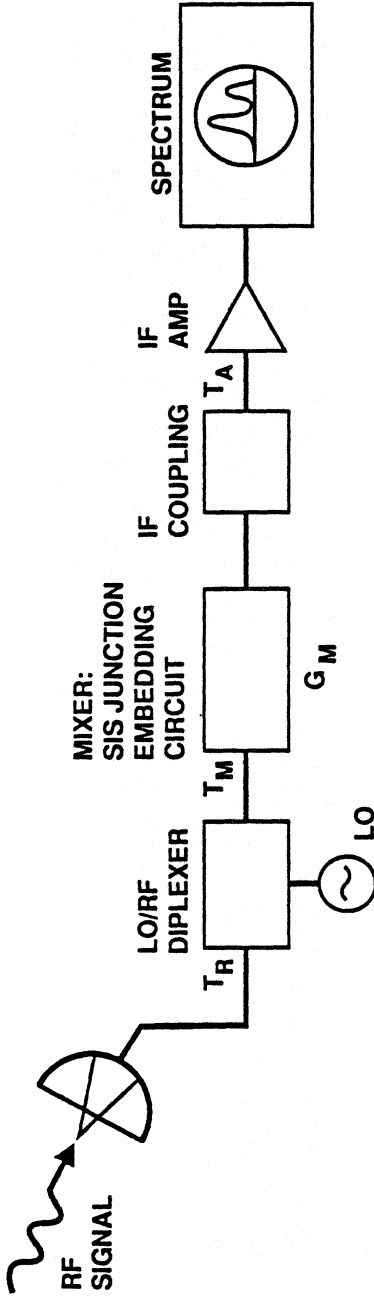


JPL

**LOW-NOISE 205GHZ SIS MIXERS USING HIGH CURRENT
DENSITY Nb AND NbN TUNNEL JUNCTIONS**

W.R. McGrath, H.H.S. Javadi, S.R. Cypher, B. Bumble, B.D. Hunt, H.G. LeDuc

**Center for Space Microelectronics Technology
Jet Propulsion Laboratory
California Institute of Technology
Pasadena, CA 91109**

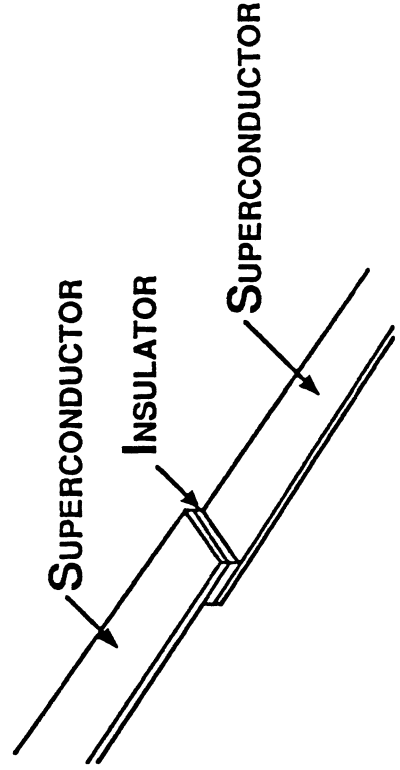
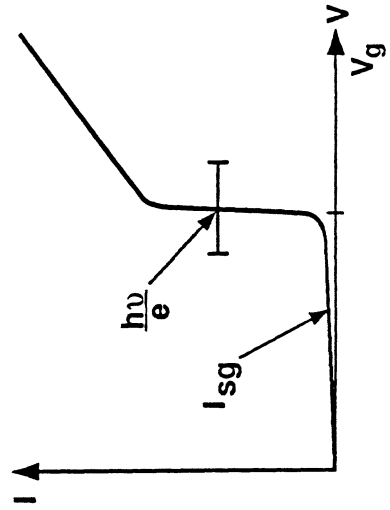


HETERODYNE RECEIVER $T_R = T_M + T_A / G_M$

SIS MIXER: $G_M > 1$, $T_M \rightarrow \frac{h\nu}{k}$, $P_{LO} \sim 50 \text{ nW}$ @ 200 GHz

IMPORTANT REQUIREMENTS: (Tucker Theory 1979)

- PROPER RF EMBEDDING CIRCUIT (TUNE OUT JUNCTION CAPACITANCE)
- IMPEDANCE MATCH AT THE IF
- SHARP NONLINEARITY $\frac{h\nu}{e} > \Delta V_g$
- LOW SUBGAP CURRENT $I_{sg} \ll \Delta I$





GOAL: Develop Low Noise SIS Mixers for Submillimeter Wave Applications using High Current Density, Submicron Area, Refractory Metal Tunnel Junctions: NbN, Nb

(Ground-based: Caltech, KAO, SMMM)

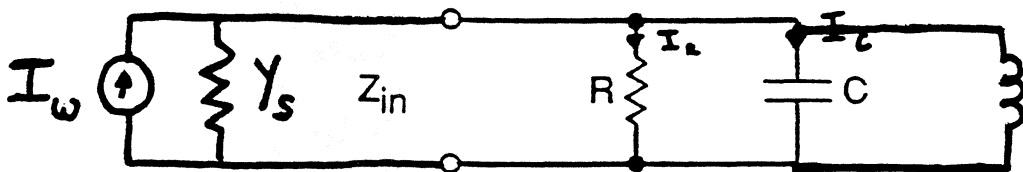
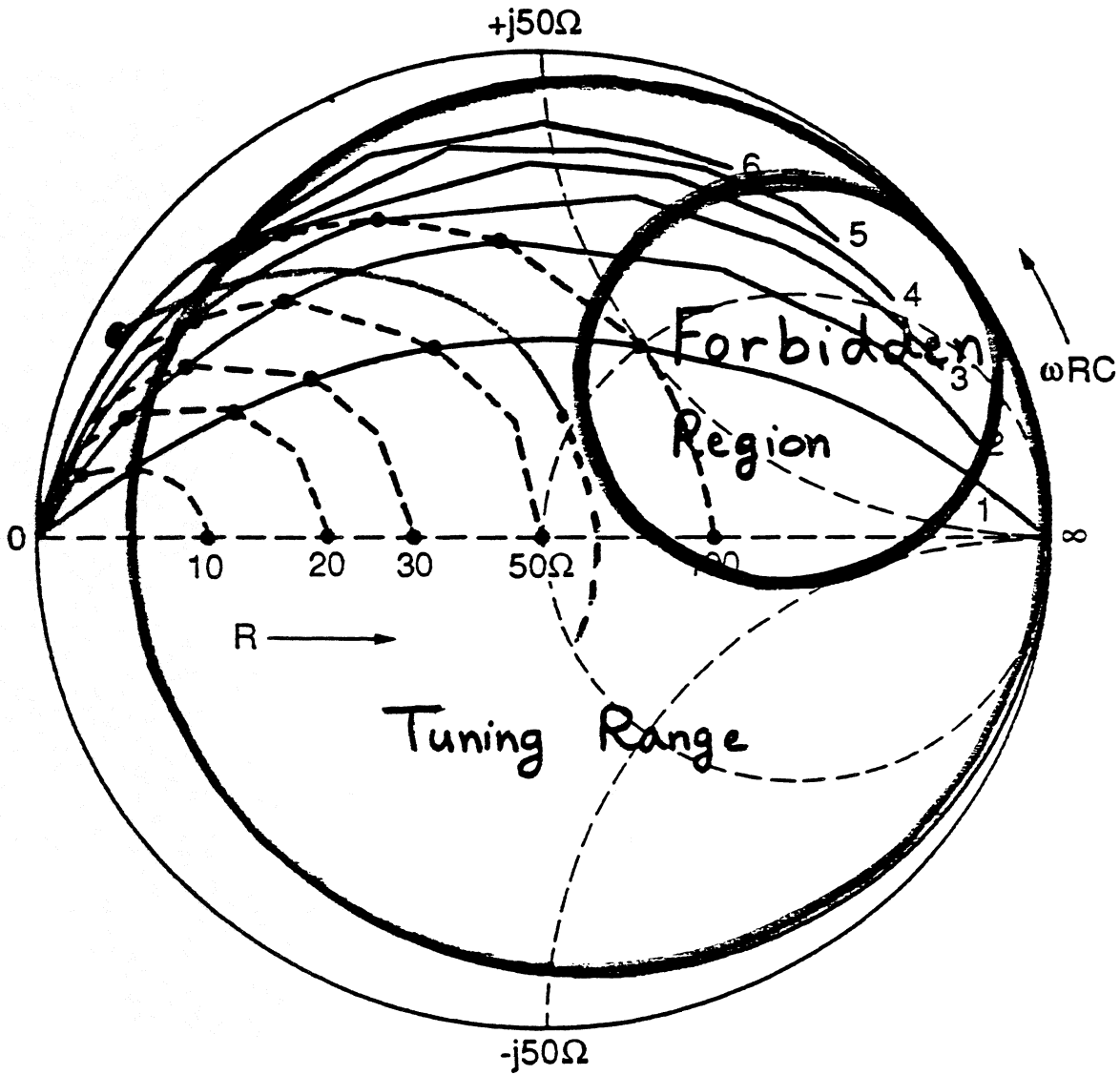
APPROACH:

- I. Area $\geq 1 \mu^2$
 Current Density J_c : moderate to high ($10^3 - 10^4$ A/cm²)
 ωRC : high (8 - 10)
 Good Mixer Performance with Integrated Tuning Elements.
 (Last year; First Space Terahertz Technology Conference)

II.

- Area $\ll 1 \mu^2$ ($0.25 \mu^2$)
 Current Density: high (10^4 A/cm²)
 ωRC : low (2 - 4)
 Excellent Mixer Performance without Integrated Tuning Elements.

Impedance Smith Chart

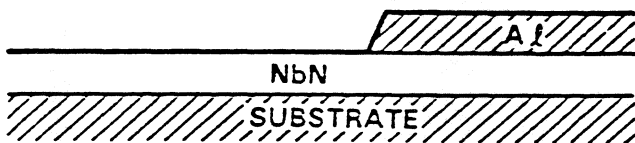


SIS Junction

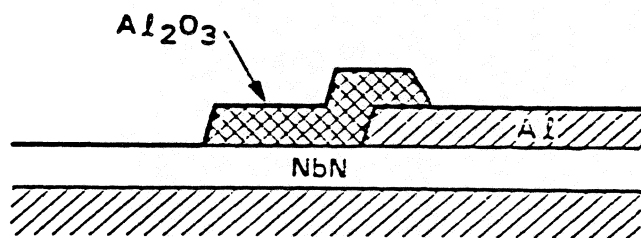
$$\omega R C = \frac{I_c}{I_r} = \frac{\omega}{\Delta\omega}$$

EDGE JUNCTION PROCESS

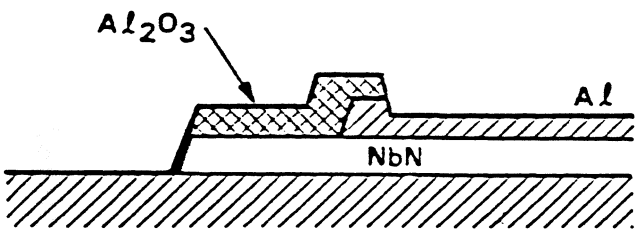
(1) SPUTTER NbN AND Al LAYERS,
PATTERN Al ELECTRODE



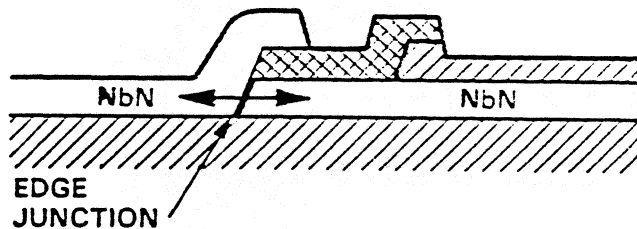
(2) LIFTOFF Al₂O₃ MILLING MASK



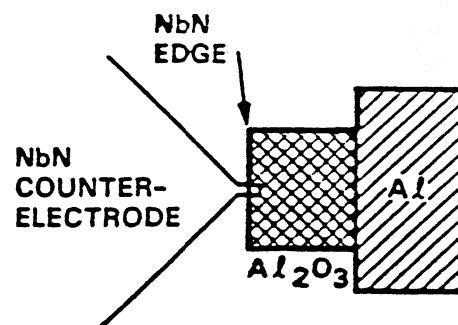
(3) ION MILL NbN EDGE



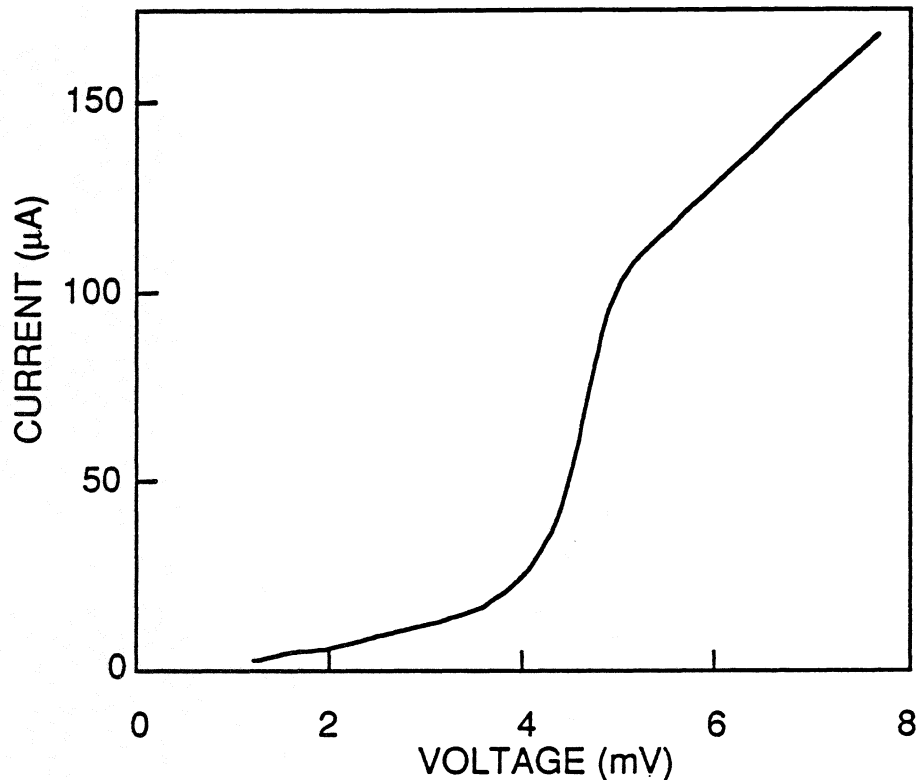
(4) SPUTTER MgO BARRIER AND NbN
COUNTER-ELECTRODE/RIE NbN



(5) TOP VIEW



NbN/MgO/NbN EDGE JUNCTION



TYPICAL JUNCTION PARAMETERS

$$\text{AREA} \approx 0.3 \mu^2 \quad J_c = 18 - 25 \text{ kA/cm}^2 \quad R = 40 - 70 \Omega$$

$$V_g = 4.8 \text{ mV} \quad \Delta V_g \approx 1 - 2 \text{ mV} \quad \frac{h\nu}{e} \approx 0.85 \text{ mV} \rightarrow \Delta V_g > \frac{h\nu}{e}$$

$$\text{Capacitance} \approx 35 - 50 \text{ fF} \quad \omega RC \approx 2.5 - 3.5 \text{ @ } 205 \text{ GHz}$$

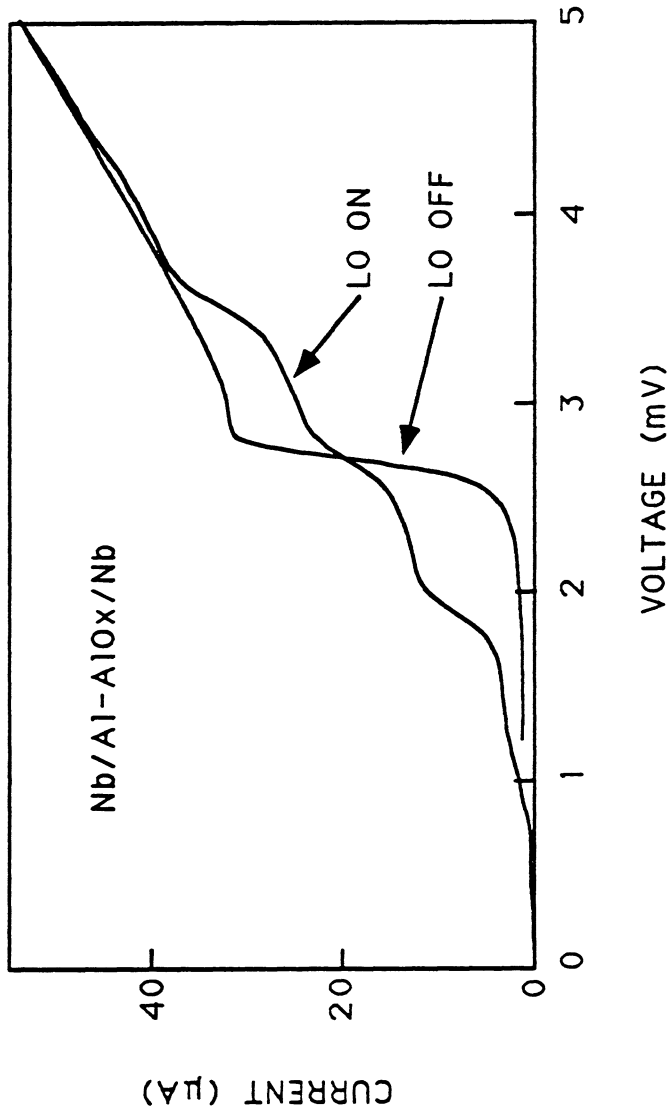
For recent improvements in edge junction I-V curves, see:

H.G. LeDuc, A. Judas, S.R. Cypher, B. Bumble, B.D. Hunt, and J.A. Stern

"Submicron Area NbN/MgO/NbN Tunnel Junctions for SIS Mixer Applications"

Applied Superconductivity Conference Proceedings, IEEE Trans. Magn. March 1991.

IV D $n10x-1Vb$ E-beam $11csq$ Junction



JUNCTION PARAMETERS

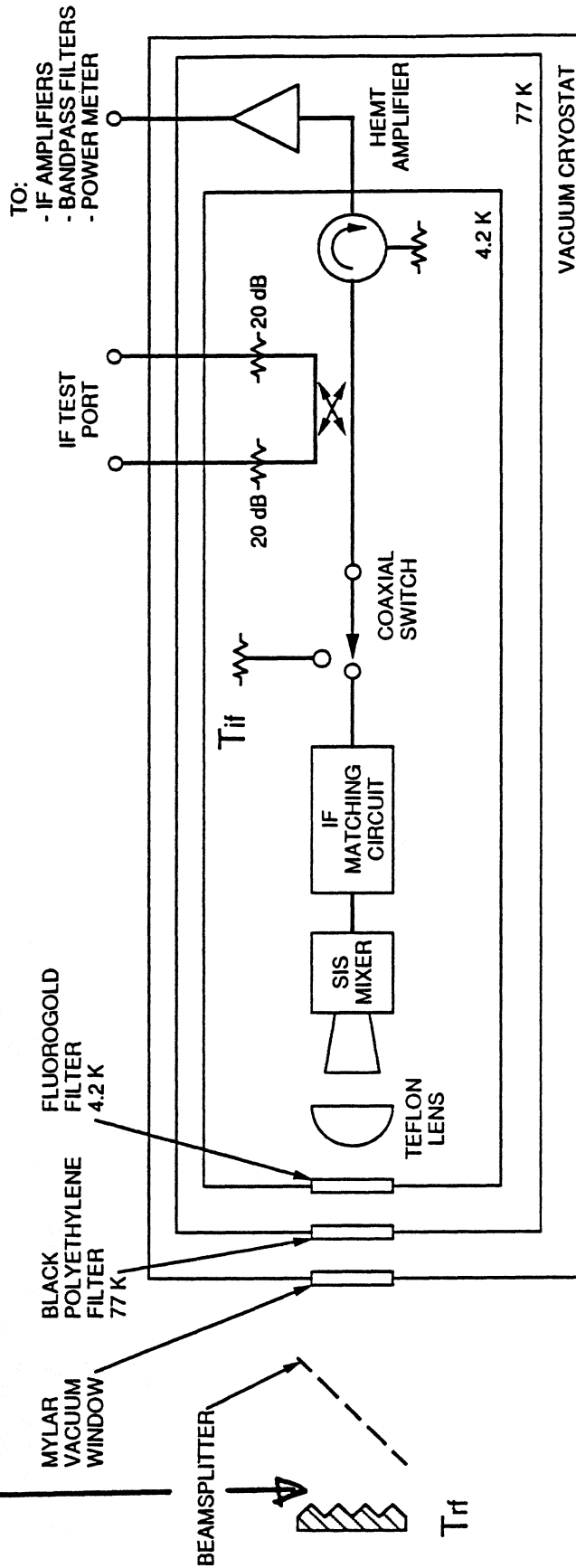
AREA $\approx 0.25 \mu^2$ $J_c \approx 10 \text{ kA/cm}^2$ $R = 95 \Omega$

$V_g = 2.7 \text{ mV}$ $\Delta V_g \approx 0.3 \text{ mV}$ $h\nu/e \approx 0.85 \text{ mV}$ $\Delta V_g < h\nu/e$

$\omega RC \approx 2$ @ 205 GHz

MIXER TEST SYSTEM

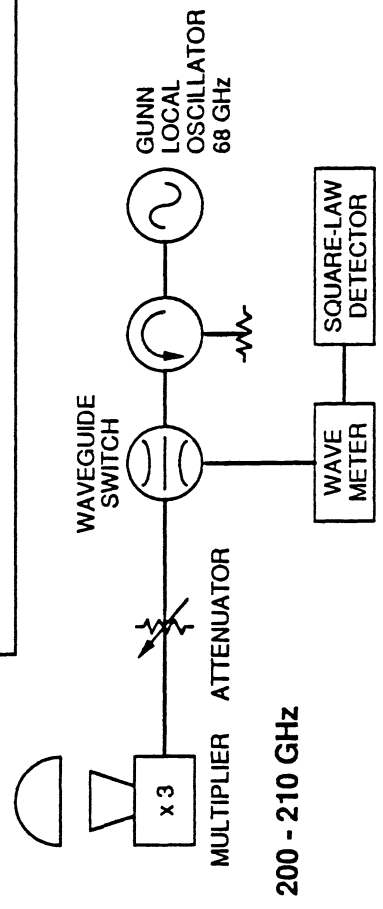
Reference Plane for T_m and G_m measurements

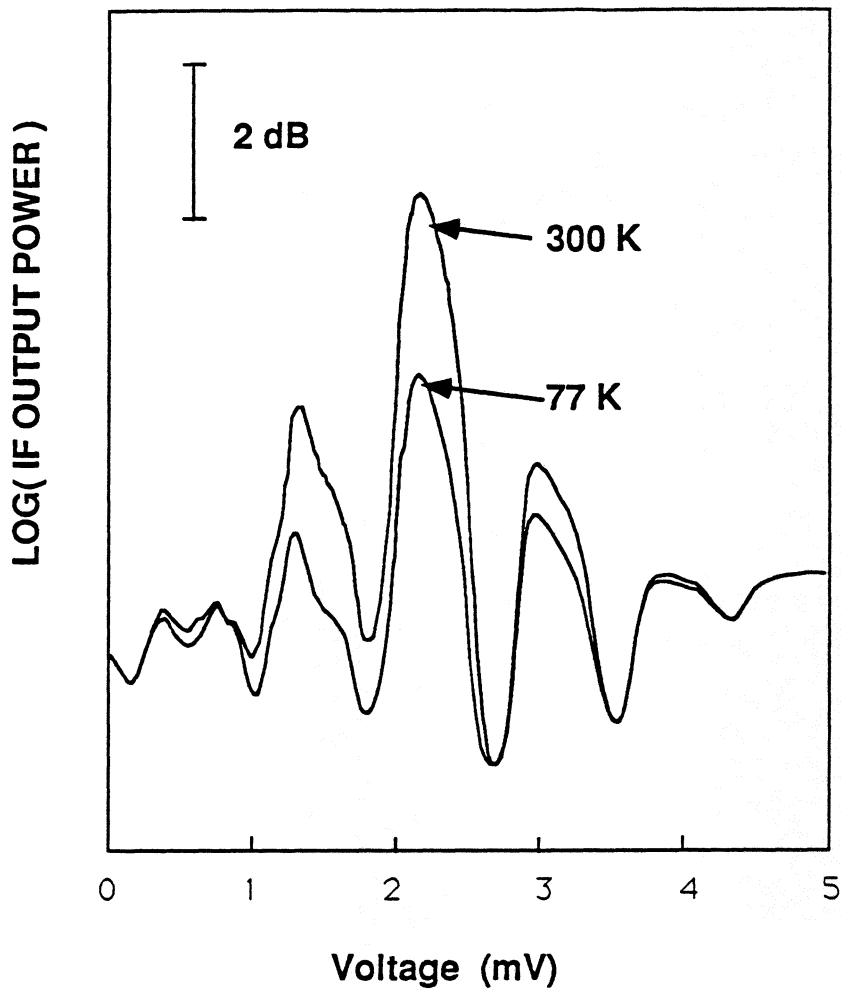


SPECIAL DESIGN if BLACKBODY

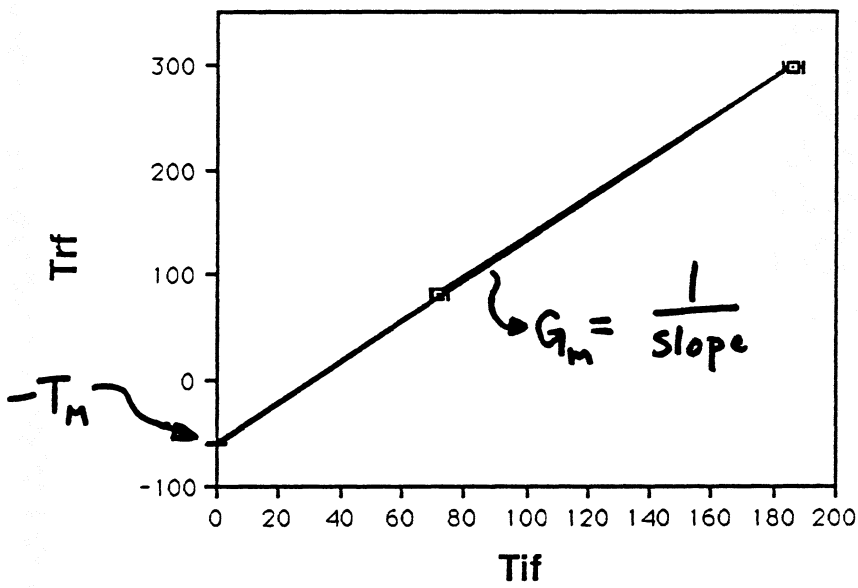
PLOT T_{rf} vs T_{if}

MIXER GAIN AND NOISE MEASURED TO $\pm 10\%$





MIXER PERFORMANCE





SUMMARY OF BEST RESULTS

JUNCTION TYPE	BATH TEMP.[K]	SIDEBAND RATIO [dB]	T_m [K]	AVAILABLE G_m [dB]	T_R^* [K] ($T_{IF}=5K$)	STUB LENGTH [μ]
Nb MESA (0.25 μ^2)	4.2	19 \pm 3	60 \pm 10	-2.1	70	NO STUB
Nb MESA (1 μ^2)	4.2	***	78 \pm 7	-6.5	100	NO STUB
NbN EDGE (0.3 μ^2)	4.2	0 \pm 3	145 \pm 10	-10.7	215	NO STUB
NbN MESA**	4.2	0 \pm 3	185 \pm 10	-12.4	290	80
	1.5	0 \pm 3	134 \pm 10	-11.2	212	80

* CALCULATED

** W.R. McGrath, K. Jacobs, J. Stern, H.G. LeDuc, R.E. Miller, M.A. Frerking, First Int. Symp. on Space Terahertz Technology, University of Michigan, 1990.

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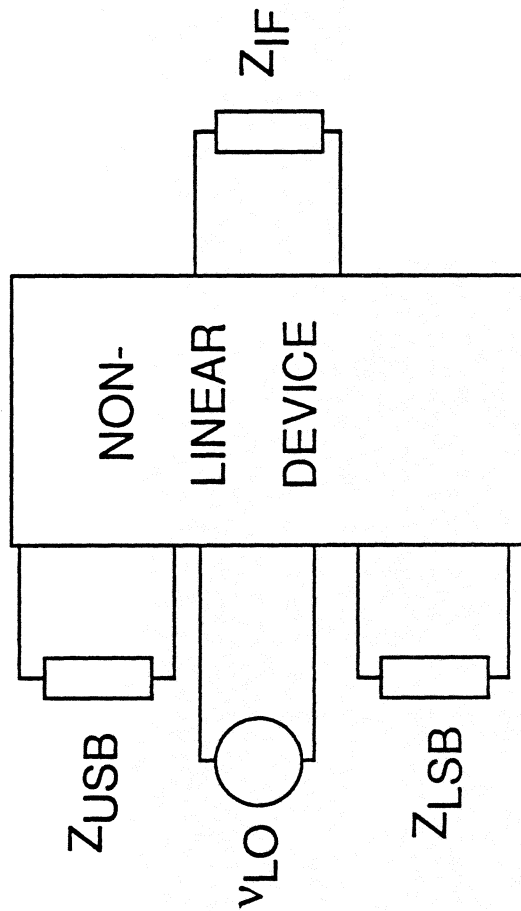
COMPUTER SIMULATION OF MIXER PERFORMANCE

Tucker Theory

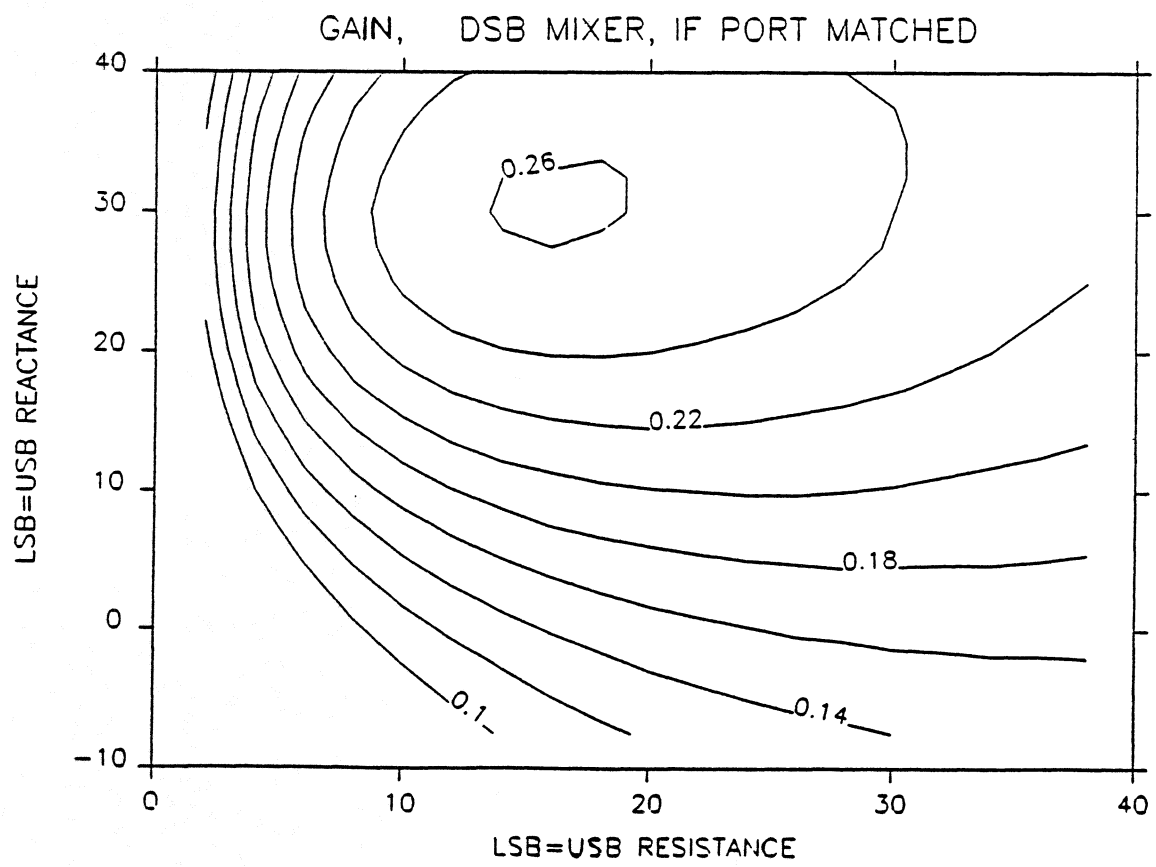
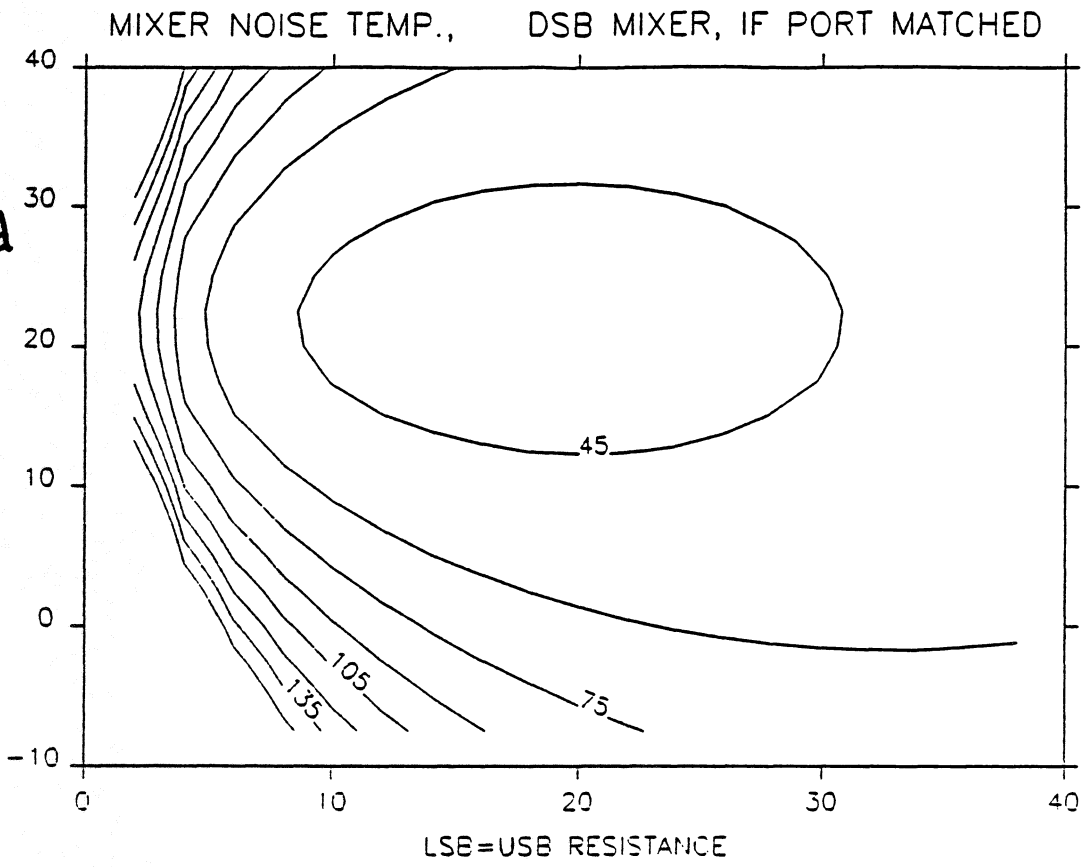
Three - Port Mixer Model

Inputs: DC I-V Curve, V_{dc} , V_{LO} , Z_{USB} , Z_{LSB} , Z_{IF}

Outputs: Mixer Noise Temperature, Mixer Conversion Efficiency

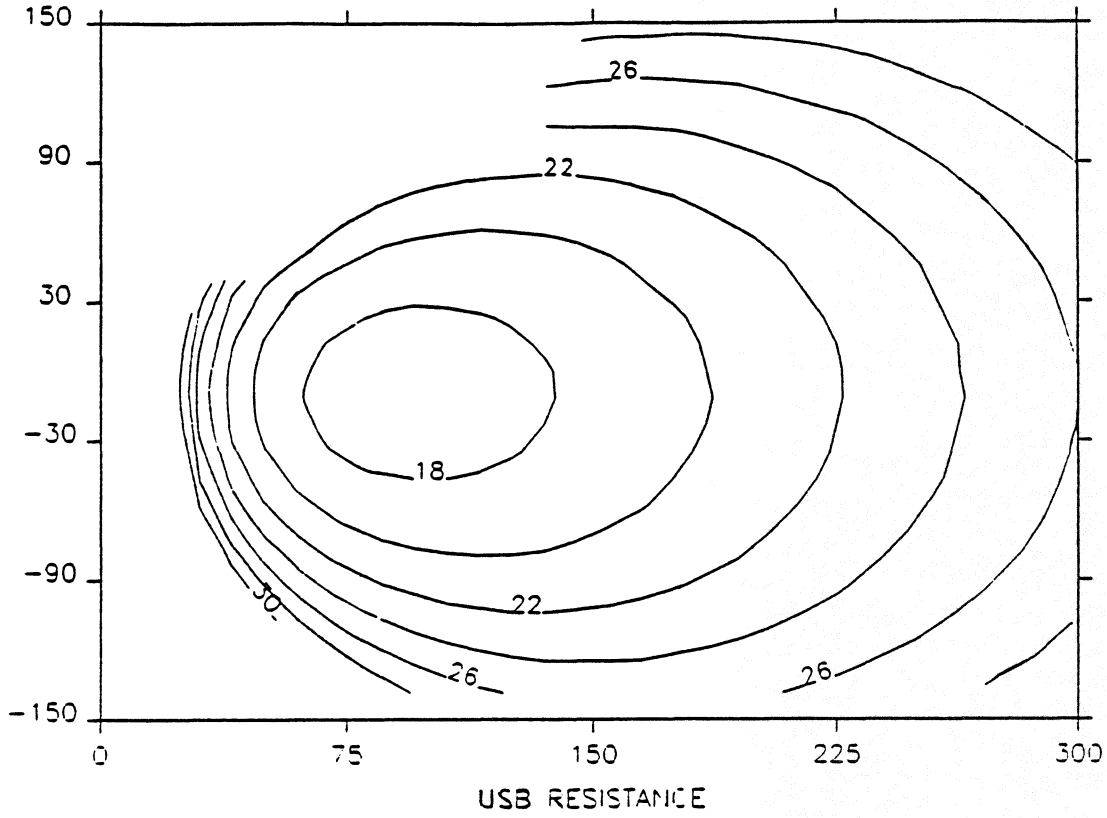


NbN
 V_b fixed
 V_{L0} Optimized

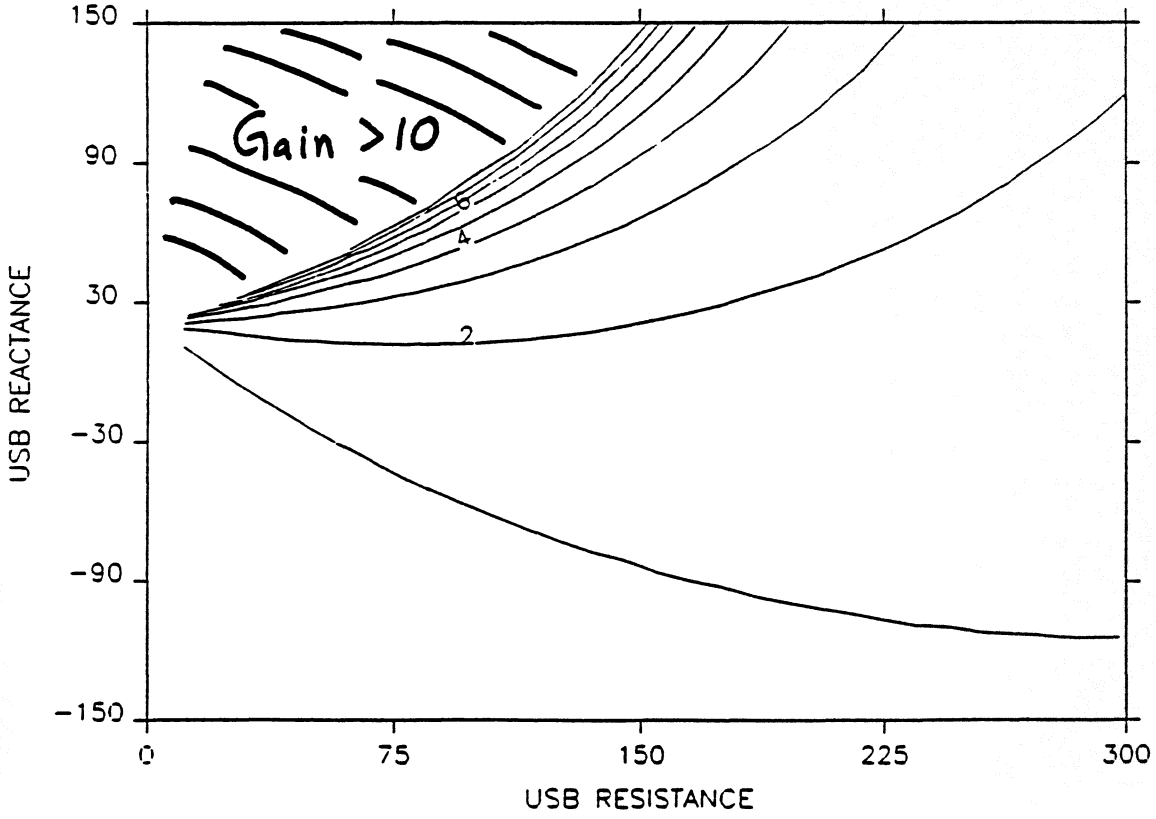


V_b
||
fixed
ω fixed

MIXER NOISE TEMP., IF PORT MATCHED



GAIN, IF PORT MATCHED



Comparison: .

	NbN		Nb	
	Gain	T_M	Gain	T_M
Tucker's Theory	-6^{dB}	45	Large	18
Experiment	-11^{dB}	145	-2^{dB}	60

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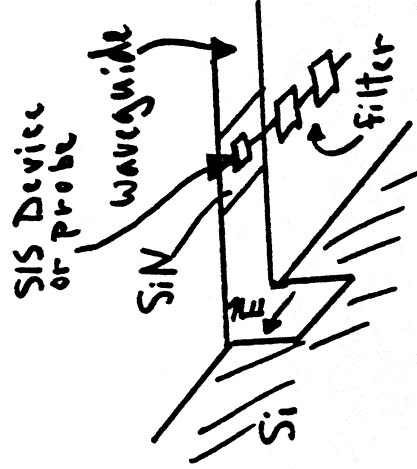
CURRENT PROGRAMS

* 630 GHz SIS MIXER ----- Presently being tested.

Waveguide Mount

NbN, Nb Tunnel Junction (JPL)

Pb-Alloy (R.E. Miller, Bell Labs)



* Si Micromachined Waveguide ----- 1000 GHz

Y.C. Tai, C. K. Walker, M. Yap: Campus
W.R. McGrath, H.S. Javadi, H.G. LeDuc: JPL

Fabricate waveguides with 1 μ thick SiN membranes in E-field dir.
Fabricate SIS junctions or probes directly in the waveguide
Solves the mounting problem !

JPL**SUMMARY**

Fabricated and tested submicron area, refractory tunnel junctions as SIS mixers at 205 GHz.

No integrated tuning elements: $\omega RC \approx 2-4$.

Accurate measurements of mixer noise and conversion efficiency.

Nb-AIOx-Nb: $T_m(SSB) = 60K$ $G_m(SSB) = -2$ dB Best to date!

NbN-MgO-NbN: $T_m(DSB) = 145K$ $G_m(DSB) = -10.7$ dB

Preliminary calculations of mixer performance with the Tucker Theory.

630 GHz SIS mixer currently being tested.

Extension of waveguide circuits to 1000GHz using Si micromachining techniques.